Docket No. 1232-4590US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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10/639,460

Confirmation No : 5736

Applicants:

10,025,10

Group Art Unit:

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Mark A. OSELE

Customer No.:

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For:

SAMPLE PROCESSING SYSTEM

Kazutaka YANAGITA et al.

REQUEST FOR CERTIFICATE OF CORRECTION OF PATENT

Mail Stop Post Issue Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

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The Commissioner is hereby authorized to charge any additional fees which may be required by this paper, or credit any overpayment to Deposit Account No. 13-4500, Order No. 1232-4590US2.

Respectfully submitted,

MORGAN & FINNEGAN, L.L.P.

Dated: September 28, 2007

 \boxtimes

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UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NUMBER 6.971.432 B2

DATED

December 6, 2005

INVENTORS

Kazutaka YANAGITA et al.

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

In Item (56), Title Page 2, Line 9, OTHER PUBLICATIONS, change:

"'Oxidized Porous Silicon and It's Application', K. Nagano et al., The Transactions of the Institute of Electronics and Communication Engineets. The Institute of Electronics, Information and Communication" to

--"Oxidized Porous Silicon and It's Application', K. Nagano et al., The Transactions of the Institute of Electronics and Communication Engineers, The Institute of Electronics, Information and Communication" .--

MAILING ADDRESS OF SENDER:

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3 World Financial Center New York, NY 10281-2101

6,971,432 B2 PATENT NO. No. of additional copies

This collection of information is required by 37 CFR 1.322, 1.323, and 1.324. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1.0 hour to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS, SEND TO: Attention Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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